

Optical Absorption Imaging by Photothermal Expansion with 4 nm Resolution

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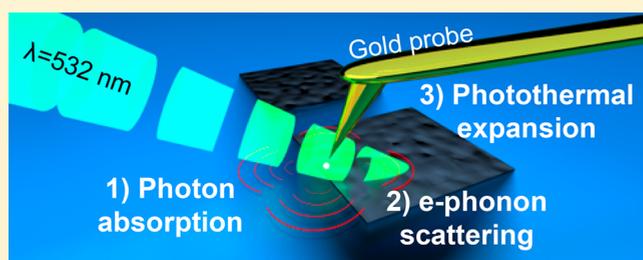
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Supporting Information

ABSTRACT: For quite a long time, one thought of the diffraction limit of light as a fundamental unbreakable barrier that prevents seeing objects with sizes smaller than half the wavelength of light. Super-resolution optical methods and near-field optics enabled overcoming this limitation. Here we report an alternative approach based on tracking the photothermal expansion that a nano-object experiences upon visible light absorption, applied successfully in the characterization of samples with a spatial/lateral resolution down to 4 nm. Our device consists of an atomic force microscope coupled with a solid-state laser and a mechanical chopper synchronized with the natural oscillation mode of an in-house-made gold tip cantilever system. This configuration enhances the detection of nanostructures due to the intermittent light excitation and the consequent intermittent thermal expansion of the sample under investigation. The sensitivity and spatial resolution are further improved by the electric field enhancement due to the excitation of localized surface plasmons at the tip apex. Our concept is demonstrated by the analysis of a two-dimensional material (GaSe) on crystalline sp^2 carbon (graphite) and by an array of multiwalled carbon nanotubes lithographically designed in a SiO_2 matrix. The photothermal expansion originating from light absorption leads to an unprecedented spatial resolution for an optical absorption event imaged below 10 nm.

KEYWORDS: nano-optics, atomic force microscopy, optical absorption, gallium selenide, carbon nanotubes, photothermal-induced resonance, photonics, thermal near field, nanoscale



In addition to the boom of super-resolution microscopy,¹ the combination of optics and scanning probe microscopy gave way to near-field methods that allow breaking the diffraction limit of light.^{2–12} However, the standard microscopy near-field methods were concentrated in the first years to develop imaging with the highest spatial resolution.^{13,14} Realizing that, contrary to standard microscopy, the image in near-field optics is produced by scattering, other tasks or other specific systems have been addressed during last years.⁴ Despite a variety of near-field optical approaches, the detection of local optical absorption is a challenging task. A considerable contribution to this field has been made by several groups, in particular by Centrone's¹⁵ and Dazzi's.¹⁶ Katzenmeyer et al. recently showed that optical absorption in photothermal-induced resonance (PTIR) could also be obtained in the visible range.¹¹ However, their findings, as well as most PTIR results reported so far, were achieved using the evanescent field experienced by the sample and originating from a prism illuminated in a total internal reflection geometry.^{15,17} Such a configuration is an efficient way to illuminate the sample but has the drawback of being limited

to samples that are either very thin or transparent. Development of PTIR allows applying it to the investigation of molecular and lattice vibrations^{17,18} and to make it competitive to a few nano-optical methods combining atomic force microscopy (AFM) and spectroscopy such as tip-enhanced Raman spectroscopy (TERS)^{6,10} or nanoinfrared.¹⁶ These approaches have been proven to be quite successful in providing information on molecular or lattice vibrations and even plasmon–phonon coupling.¹⁹ A comprehensive survey of the development and the present status of PTIR can be found in the recent review by A. Dazzi.²⁰ This is particularly the case in AFM-IR and PTIR, which use excitations in the infrared (IR) spectral range. It is then possible to obtain the same information as in a conventional IR spectrometer but with an impressive nanoscale resolution.²¹ It is also noticeable that the IR-tunable pulsed lasers used in PTIR can cost as much as the AFM setup itself, making the generalization of this method

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67 even more difficult. In this work, we implement a new concept
68 for photothermal expansion in the visible range that overcomes
69 all the limitations mentioned above. Contrary to most previous
70 reports based on the tracking of photothermal expansion due to
71 excitation of molecular vibrations,¹⁸ we aim at investigating the
72 photothermal expansion due to optical absorption in the visible
73 range and its nanoscale mapping with AFM. We refer to this
74 method as *nano-vis*, with its physical mechanism of operation
75 depicted in Figure 1a. Upon resonant photon absorption and

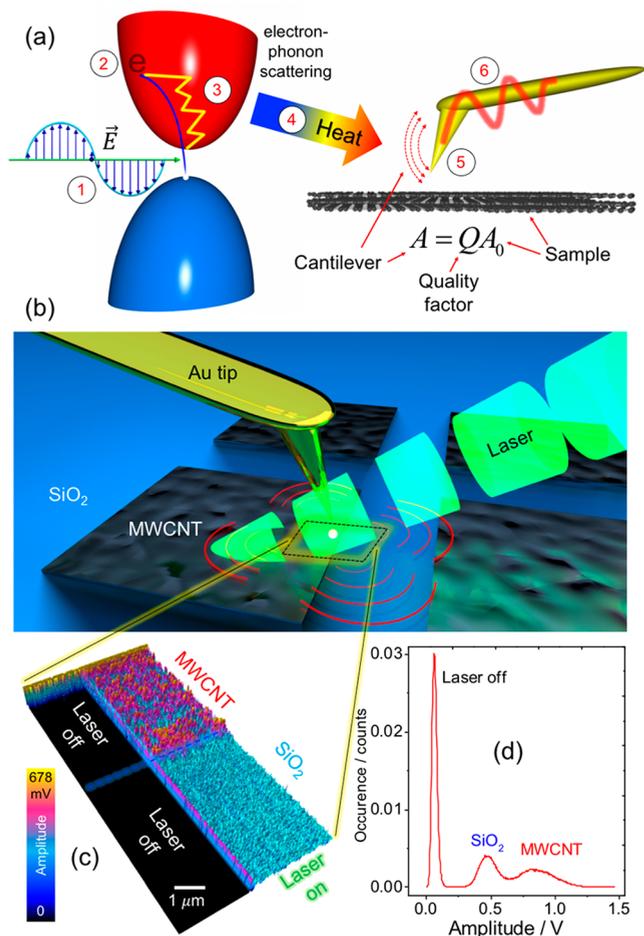


Figure 1. (a) Physical schematics behind nano-vis: (1) a photon with energy well above the energy band gap excites an electron from the valence band to a higher energy level (2) in the conduction band, nonradiative relaxation (3) mediated by e-phonon scattering induces (4) heat generation that results in the thermal expansion of the sample (5) and the cantilever deflection (6). (b) Schematics of the nano-vis experiment with an Au cantilever tip and an MWCNT sample illuminated by a chopped laser beam. (c) Photothermal amplitude image of the MWCNT/SiO₂ interface with half of the image acquired in the dark, laser off. (d) Histogram of the photothermal expansion image shown in (c).

76 excitation of electrons to higher energy levels in a molecule or
77 crystal, the nonradiative relaxation of charge carriers induces
78 local heating due to electron–phonon scattering. This heating
79 produces the thermal expansion of the nano-object under
80 investigation. The local change of sample size is detected and
81 mapped using an atomic force microscope, allowing in this way
82 the indirect visualization of light absorption. It is necessary to
83 keep in mind that different processes occurring on different time
84 scales, with respect to the modulation frequency, should weight

their contribution to the result, and the whole chain of the 85
transformation of the absorbed light into the AFM signal 86
described schematically also includes the thermal conductivity 87
and the elasticity of the object under investigation. Moreover, 88
the registered value proportional to the absorption is also 89
defined by the quantum efficiency of the heat generation, 90
expansion coefficient, and local amount of the absorbing 91
material and depends on the thermal and elastic interactions 92
with the local environment. The signal is produced by a 93
complex mixture of physical parameters from the sample. It is 94
necessary to note in the interpretation that the proposed 95
method is not a straightforward detection of the absorption 96
coefficient, but perhaps it is the only present approach to 97
characterize the absorption at the nanoscale. Similarly to PTIR, 98
the spatial resolution of nano-vis should be limited by the 99
dimensions of the tip apex used in AFM and local field 100
distribution and enhancement around the tip–surface contact. 101
In Table S1 we summarize the main differences between nano-vis 102
and PTIR. Our concept is based on the use of continuous 103
wave (cw) lasers that can be as inexpensive as conventional 104
laser pointers. From one side, the system with several lasers 105
restricts the spectroscopic possibilities of the method, but 106
usually features in the visible spectra are not so narrow as in IR; 107
thus a high spectral resolution may not be necessary. 108
Additionally, having no limitation on the quality of the light 109
excitation like in Raman spectroscopy, further development 110
with the use of a monochromator for the illumination at 111
different wavelengths is probably possible. An intermittent 112
illumination procedure was established to increase the 113
sensitivity of the system to the small sample deformation 114
caused by thermal expansion. Our strategy is based on using a 115
conventional chopper at a frequency matching the mechanical 116
resonance of the AFM cantilever. This results in the resonant 117
enhancement of the cantilever oscillation amplitude induced by 118
the mechanical excitation from the sample. We used a fully 119
metallic Au cantilever with eigenfrequencies below 10 kHz. 120
These metallic probes add the advantage of acting as a highly 121
confined light source due to the excitation of localized surface 122
plasmons at the tip apex. The plasmonic contribution to nano-vis 123
helps to improve the spatial resolution and sensitivity, as 124
shown recently by Belkin’s group.¹⁸ We aim at the widespread 125
implementation of nano-vis using off-the-shelf components—a 126
cantilever, chopper, and cw laser—for nanoscale visible 127
absorption imaging with a record spatial resolution below 10 128
nm. 129

RESULTS AND DISCUSSION

Proof-of-Concept: Imaging a Carbon Nanotube/Glass

Interface. Two different sample kinds were investigated. The 131
first one was a two-dimensional layered material (GaSe) 132
deposited by mechanical exfoliation on a freshly cleaved 133
graphite substrate (HOPG).²² The second sample consists of 134
vertically aligned multiwalled carbon nanotubes (MWCNTs) 135
embedded in a SiO₂ matrix lithographically defined.²³ In this 136
latest sample, two different MWCNTs were investigated: 137
square-shaped MWCNTs that show a sharp SiO₂/MWCNT 138
interface and MWCNT circular vias. Fully metallic Au 139
cantilevers²⁴ were used in the AFM experiments operated in 140
contact mode. The cantilever dynamic response²⁵ was 141
experimentally determined using an AC piezoelectric excitation 142
and tracking of the cantilever oscillation amplitude in the range 143
from 1 to 10 kHz. 144
145

146 For the nano-vis experiments, the AC piezoelectric excitation
 147 was switched off, and the laser chopper frequency was set to the
 148 resonance of the cantilever found in that frequency range. The
 149 AFM was operated in contact mode during nano-vis. Contrary
 150 to previous realizations of PTIR in the visible range¹⁷ we use
 151 external illumination and inexpensive off-the-shelf optical
 152 components that make a simplified optical scheme. Moreover,
 153 we consider the external illumination as the principal difference
 154 between the two approaches. On one side, the direct tip
 155 illumination makes its own thermal expansion, but the
 156 illumination in total internal reflection geometry does not
 157 exclude this effect if the prism coverage is not completely
 158 opaque. Furthermore, the scheme with internal reflection is
 159 the standard for the so-called photon tunneling (PSTM).
 160 PSTM is a variation of scanning near-field optical microscopy
 161 (SNOM) where the local field excites the tip and the scattered
 162 signal is defined by the sample's topography.²⁶ This local field
 163 would be enhanced and rescattered by the tip interacting with
 164 the surface; thus this process could increase the topographic
 165 artifacts in PTIR with internal illumination of the object. An
 166 additional problem of the internal illumination is the difference
 167 of the absorption point situated at the prism–specimen
 168 boundary and the tip situated on the other side of the prism
 169 coverage. In such a case the registered signal will be affected by
 170 local stiffness and elasticity of the specimen and distorted if not
 171 seriously corrupted. The nano-vis imaging results of the
 172 MWCNT structure shown in Figure 1c confirm the working
 173 principle of our method. It is worth noticing that the
 174 mechanical and chemical polishing of the sample minimizes
 175 the topography differences at the interface. This a crucial point
 176 to separate the optical absorption effects from topographic
 177 artifacts that could influence the nano-vis contrast. Figure 1c
 178 also shows that the contrast completely disappears when the
 179 laser excitation is turned off. The amplitude distribution (how
 180 often a given amplitude value appears in the image) in Figure
 181 1d clearly shows the different contributions to the nano-vis
 182 contrast, as well as its decrease when the laser was turned off.
 183 Similar results showing no contrast were obtained for direct
 184 illumination not modulated by the chopper and for chopper
 185 frequencies much higher or lower than the resonance frequency
 186 of the cantilever; see Figure S3 in the Supporting Information.
 187 These results confirm the origin of the cantilever amplitude
 188 contrast as being due to the photothermal expansion after
 189 optical absorption takes place.

190 **Mechanical Resonance Matching: The Key to Achieving High Sensitivity.** The typical AFM deflection sensitivity is
 192 in the range of 0.1 nm, depending on the optical lever system
 193 used for detection. Nano-vis can be sensitive to the thermal
 194 expansion of the sample well below that threshold. This high
 195 sensitivity is due to the amplification of the cantilever
 196 oscillation amplitude (A) at resonance. This amplification
 197 occurs when the sample expands and contracts at a frequency
 198 matching a mechanical eigenfrequency of the cantilever, making
 199 it oscillate at Q (the cantilever quality factor) times the
 200 amplitude of the sample ($A = QA_0$). It is this resonance
 201 condition that makes possible achieving the high picometer
 202 sensitivity down to the expansion of a single molecular layer in
 203 the near-IR regime reported previously.¹⁸ In Figure S3 of the
 204 Supporting Information, nano-vis images with the chopper in-
 205 and off-resonance illustrate this point. If the frequency of the
 206 chopper is detuned from the cantilever resonance (Figures S3
 207 and S8) or the sample is illuminated without a chopper or
 208 without the laser (Figures S4 and S8), then a decrease in the

nano-vis contrast is observed. These results provide additional
 209 confirmation of the physical photothermal origin and
 210 mechanical resonance dependent sensitivity of the system. A
 211 similar approach was recently used. Greco et al. reported on the
 212 exploitation of mechanical resonances in a cantilever to study
 213 the plasmonic amplification of a single hotspot with modulated
 214 Raman spectroscopy.²⁷ 215

Spatial Resolution below 10 nm. The spatial resolution
 216 of this system is obtained from the cross-sectional analysis in
 217 Figure 2. The topography and amplitude images are shown in 218

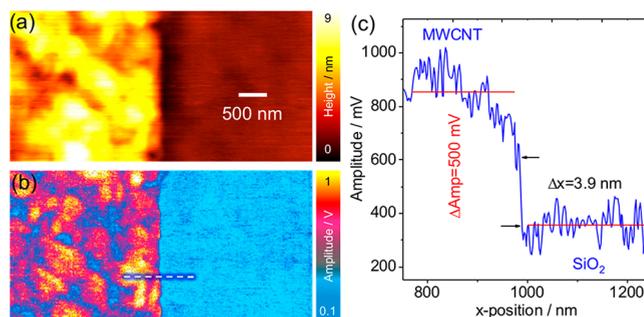


Figure 2. (a) AFM topography image of the MWCNT/SiO₂ interface. (b) Photothermal expansion image (amplitude) showing that the spatial resolution is below 10 nm, limited by the pixel size as shown in the cross-section profile in (c).

Figure 2a,b. The cross-section analysis of the amplitude image
 219 in Figure 2c shows a remarkable spatial resolution below 10
 220 nm, only limited by the pixel size. Figure 2b even shows some
 221 features on the MWCNT not visible in the topography image.
 222 These features might be hidden by the tip imaging effects in the
 223 topography that are overcome by nano-vis. Notice that when
 224 investigating other kinds of samples, the high spatial resolution
 225 of ~ 4 nm we obtain might vary in other nanoscale systems
 226 having larger sample topography features than the sample
 227 shown in Figure 2. 228

The complementarity between the topography and the nano-
 229 vis images can be further visualized from the statistical
 230 distribution of topography and amplitude values in Figure S5.
 231 This analysis shows the noncorrelation between the topography
 232 and nano-vis results. If there was a full correlation between the
 233 two data sets, then their distributions would also be similar. But
 234 as shown in Figure S5, the nano-vis statistical distribution of the
 235 contrast can be deconvolved by three Gaussian peaks. The
 236 peaks were numerically fit without constraints, reaching an
 237 accuracy of 99.9% to the experimental data. Contrary to the
 238 contrast for the nano-vis image, the height distribution has
 239 several contributions that span a broad range. This is
 240 representative of the different topographical features of the
 241 MWCNT region. 242

Nano-vis in 2D Materials: Visualizing Subnanometer Defects in Graphite. Now we turn our focus to the second
 243 sample reported in this study: one van der Waals material on
 244 top of another one, GaSe on HOPG, shown in the topography
 245 AFM image in Figure 3a. The deflection (error) image in
 246 Figure 3b shows the homogeneity of the scanning except at the
 247 interface due to changes in topography. The photothermal
 248 image in Figure 3c, on the other hand, shows a clear contrast
 249 between the HOPG and GaSe surfaces. Similarly to the case of
 250 the MWCNT, a part of the image was acquired by turning the
 251 laser off (top side in Figure 3c). In the photothermal image in
 252 Figure 3c, we also observe a stripe-like region giving higher 253
 254

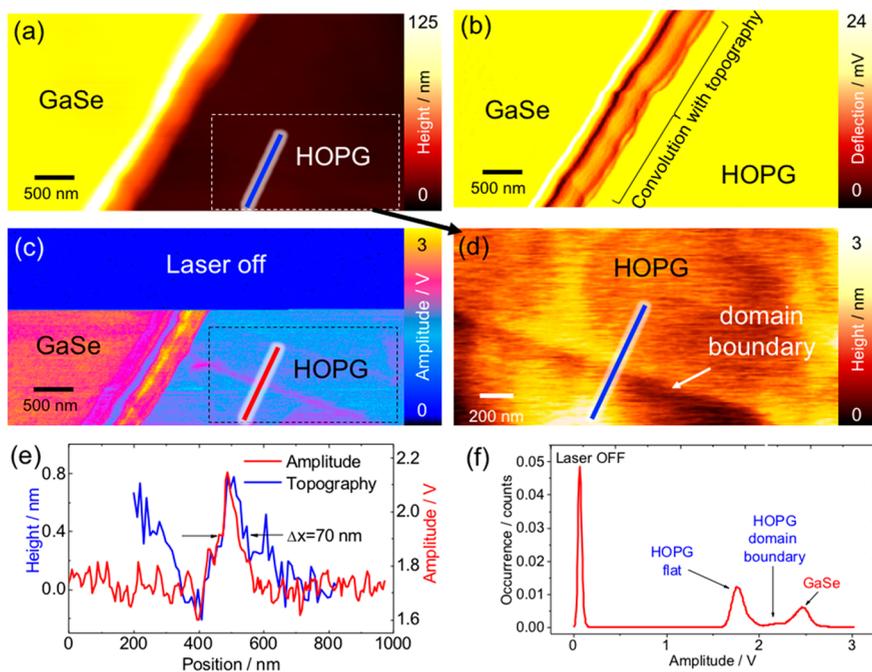


Figure 3. (a) Topography and (b) cantilever deflection image of GaSe on HOPG. (c) Photothermal expansion image with the laser off (top) and laser on (bottom) at the GaSe/HOPG boundary. (d) Zoom-in in the topography of the region marked in (a) and (c) showing a domain boundary in HOPG. (e) Cross-section profiles of the HOPG domain boundary in the regions marked in the photothermal and topography images (a) and (c). (f) Histogram of the photothermal expansion image showing the amplitude distribution for the different tip–sample configurations, including the contribution from the domain boundary.

255 contrast than the rest of the HOPG surface. This feature on
 256 HOPG is not readily visible in the topography or deflection,
 257 Figure 3a and b, respectively. For clarity, this region was
 258 zoomed-in around the area indicated by the dashed rectangle in
 259 Figure 3a and c. The zoom-in of the topography image is
 260 shown in Figure 3d. The photothermal and topography cross-
 261 sections in Figure 3d are indicated in the images by red and
 262 blue lines in Figure 3b and c, respectively. The cross-section
 263 profiles across the stripe region on HOPG in Figure 3d show
 264 that it consists of a domain boundary of 0.8 nm height. The
 265 lateral size of the stripe of about 70 nm can be determined from
 266 cross sections made on both the topography and the nano-vis
 267 images. Boundaries and folds in graphite can be expected to
 268 have higher absorption than its pristine counterpart since such
 269 defects add new states for electronic transitions as well as
 270 increasing the scattering probability of photoexcited charge
 271 carriers. However, one more contribution to the contrast in
 272 nano-vis is related to the heat dissipation of the sample. This is
 273 discussed below in more detail. Thus, the higher nano-vis
 274 contrast for the domain boundary in HOPG may also be
 275 related to the defects introduced by the domain boundary that
 276 minimize the heat conductivity. This result implies that the
 277 nano-vis image has at least the same spatial resolution as the
 278 topography obtained by AFM. This observation validates our
 279 hypothesis that the lateral spatial resolution in optical
 280 absorption and photothermal expansion of nano-vis are limited
 281 by the tip size. The effect from the domain boundary is also
 282 visible in the amplitude distribution shown in Figure 3f by a
 283 small bump below the GaSe peak. This result implies that our
 284 method is even sensitive to nanoscopic features with slight
 285 differences in optical absorption or heat conductivity. Further
 286 application of this method to nanoscaled carbon with sp^2
 287 hybridization (single-walled carbon nanotubes and graphene)
 288 could provide new significant insights into the physical and

optical properties of these nanomaterials as well as other two- 289
 dimensional semiconductors such as MoS_2 and membrane-like 290
 metamaterials.²⁸ 291

Another observation from the results shown in the deflection 292
 image of Figure 3b is the similar contrast between the GaSe and 293
 HOPG regions of the sample. The only contrast in cantilever 294
 deflection appears at the GaSe/HOPG interface due to the 295
 signal convolution with topographical changes of the sample. 296
 This result helps us to rule out topographic effects on the nano- 297
 vis contrast. It is understandable that the topographical effects 298
 are not dominant since both sides of the sample have a 299
 roughness (RMS) below 0.5 nm. Similarly, since the domain 300
 boundary topography does not even reach 1 nm in height, we 301
 can confidently rule out the topography contribution to the 302
 nano-vis image of the graphite domain boundary shown in the 303
 cross-section (Figure 3e). Topographical and nano-vis (photo- 304
 thermal expansion) data show a correlation between regions 305
 that considerably well absorb light (GaSe and MWCNT) and 306
 regions with lower absorption or reflective areas (SiO_2 and 307
 HOPG, respectively). We verified that exciting the sample by a 308
 laser modulated with a chopper set around the mechanical 309
 resonance frequency of the cantilever resulted in well-resolved 310
 image contrast. Moreover, we observed the decrease in contrast 311
 either when the sample was constantly illuminated (non- 312
 modulated laser) or when the laser was turned off. In this latter 313
 case, the image contrast was absent entirely. 314

These observations confirm that our results, and particularly 315
 the image contrast in nano-vis, can be attributed to the optical 316
 absorption of the sample with a likely contribution from the 317
 thermal properties of the sample. Moreover, for a single domain 318
 of the sample, defects on HOPG or in MWCNTs increase the 319
 phonon scattering, which has an impact on the thermal 320
 conductivity of the sample and, therefore, also impacts the 321
 nano-vis contrast. This thermal contribution is discussed in 322

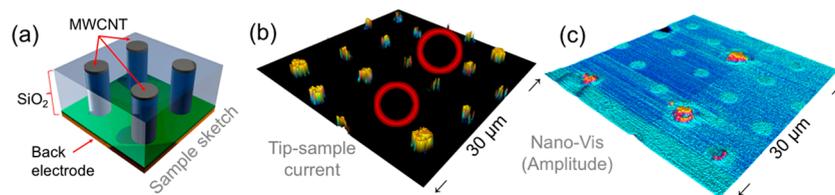


Figure 4. (a) Schematics of the MWCNT sample consisting of vertically grown nanotubes in a SiO₂ matrix. (b) CSAFM image showing a map of the tip–sample current obtained under 200 mV bias. The interconnects marked with circles show no current response. (c) Nano-vis image obtained simultaneously to the current showing a higher absorption than for the vias with no current.

323 more detail below. Regarding the role of the plasmonic tip,
 324 notice that the same kind of tip was experimentally shown to
 325 produce significant confinement of the electromagnetic field
 326 that allows obtaining optical spectroscopy images well beyond
 327 the diffraction limit of light.^{6,29} We demonstrate the electric
 328 field localization and amplification by the sequential imaging
 329 with nano-vis and tip-enhanced Raman spectroscopy of a SiO₂/
 330 Si nanostructured sample. The results that are shown in Figure
 331 S8 evidence the nanoscale resolution of TERS and nano-vis;
 332 since the plasmonic effects of the tips used are critical for the
 333 nanoscale imaging capability of TERS, we expect that the same
 334 effects must also play a role in nano-vis. To definitively answer
 335 this question, a comparative nano-vis study using plasmonic
 336 and nonplasmonic tips could shed light on the role of
 337 plasmonic contributions to nano-vis. Moreover, the TERS
 338 results illustrate the possibility to combine nano-vis with other
 339 tip-enhanced methods and advanced scanning probe micros-
 340 copy as shown below with electrical AFM.

341 **Simultaneous Nano-vis and Electrical AFM: Defects in**
 342 **Carbon Nanotube Interconnects.** After demonstrating the
 343 possibility to map the optical absorption and photothermal
 344 expansion with nanoscale resolution, as shown above, we aim
 345 now at exploiting this method to address a different question
 346 related to a technological challenge that concerns the
 347 development and application of multiwall carbon nanotube
 348 interconnects. This emerging technology has the potential to
 349 substitute conventional electronics based on copper through
 350 silicon vias. However, one issue of MWCNT interconnects is
 351 the contact resistance between the back-metal contact and the
 352 carbon nanotubes vertically grown in a SiO₂ matrix as shown in
 353 Figure 4a. In a previous work, we reported on the nanoscale
 354 characterization of such devices using conductive AFM
 355 (CSAFM), demonstrating the issue of contact resistance.³⁰

356 CSAFM images of the current that flows through the AFM
 357 tip in response to a potential difference applied between the tip
 358 and the sample. However, the reason that some of the devices
 359 displayed poor electrical contact was not fully clear. To offer
 360 new insights into this question, an MWCNT interconnect
 361 sample was analyzed in real time with both nano-vis and
 362 CSAFM, providing the imaging results shown in Figure 4. The
 363 current map acquired during CSAFM shows the conductivity of
 364 MWCNT vias, although there are also two vias marked by
 365 circles in Figure 4b that do not conduct. In the nano-vis result
 366 in Figure 4c, we found a high contrast for some of the
 367 MWCNT vias. From the CSAFM and nano-vis results in Figure
 368 4b and c we observe that the two vias that ultimately failed in
 369 conducting are precisely the same vias that show the highest
 370 nano-vis contrast. In fact, the electrical failure is related to the
 371 resistance issues for the circuit break with no indication of
 372 exactly where the break occurs, either between the MWCNT
 373 and the back electrode as previously reported or at the top side
 374 of the MWCNT with the tip. By comparing the current

375 distribution with nano-vis, we must notice that the higher
 376 contrast in nano-vis observed for the vias that failed to conduct
 377 current should be a consequence of poor contact between the
 378 MWCNT and the back-metal electrode. In the absence of good
 379 contact with the back electrode, the MWCNT vias would be
 380 more thermally insulated in the SiO₂ matrix. Indeed, this
 381 observation opens one crucial question: how do the differences
 382 in heat dissipation affect the image contrast? This is a key point
 383 since understanding the role of heat dissipation opens
 384 perspectives toward using nano-vis for the quantification of
 385 thermal properties of materials at the nanoscale. For the sake of
 386 completeness, we must notice two vias situated on the left and
 387 bottom corners in Figure 4b,c, which show both good
 388 conductivity and nano-vis contrast. At the moment we cannot
 389 present a clear explanation for this, which demands further
 390 investigations. Answering these questions is currently the next
 391 step in our research. Meanwhile, in the last part of this work, we
 392 briefly discuss the heat dissipation contribution to the image
 393 contrast in nano-vis.

394 **Defects and Heat Dissipation Contribution to Nano-**
 395 **vis.** In Figure 2b, we see clearly resolved at the nanoscale that
 396 the MWCNT region is not homogeneous. The different
 397 structures that are blurred in the topography are discernible in
 398 the nano-vis image. To illustrate this point, we have marked a
 399 band region delimited by dashed lines in Figure S6a. While this
 400 band appears homogeneous with high topography, in the nano-
 401 vis image in Figure S6b we see other details not visible in
 402 topography. To understand these heterogeneities, we take a
 403 look at the MWCNT cross-section view by scanning electron
 404 microscopy of a similar structure previously reported by us and
 405 others; see Figure S6c.³⁰ We observe that the MWCNTs do not
 406 fill all the space in the vias but that there are some voids. One
 407 possible explanation for the heterogeneous contrast observed in
 408 nano-vis can be associated with the voids in the MWCNT
 409 region. Overall, there is some correlation between the height of
 410 the MWCNT and the nano-vis contrast; this is understandable
 411 since more material implies larger absorption and thus larger
 412 thermal expansion. However, the more detailed contrast that is
 413 not correlated to the topography can be related to subsurface
 414 features of the MWCNTs like the voids. This can be expected
 415 as due to two contributions from the voids to the image
 416 contrast. First, as discussed above, more material implies more
 417 chances the photons will be absorbed, resulting in larger
 418 thermal expansion. Second, the presence of voids below the
 419 surface induces a decrease in the thermal conductivity, which
 420 will then result in an increase in contrast due to a larger
 421 localized heat that cannot be so easily dissipated as in the
 422 regions without voids. Since these two contributions go in
 423 opposite directions in terms of thermal expansion, pinpointing
 424 the exact physical origin of this detailed contrast still eludes us.
 425 This indicates a line of study to be addressed in follow-up
 426 works. Under the hypothesis that the main contribution to

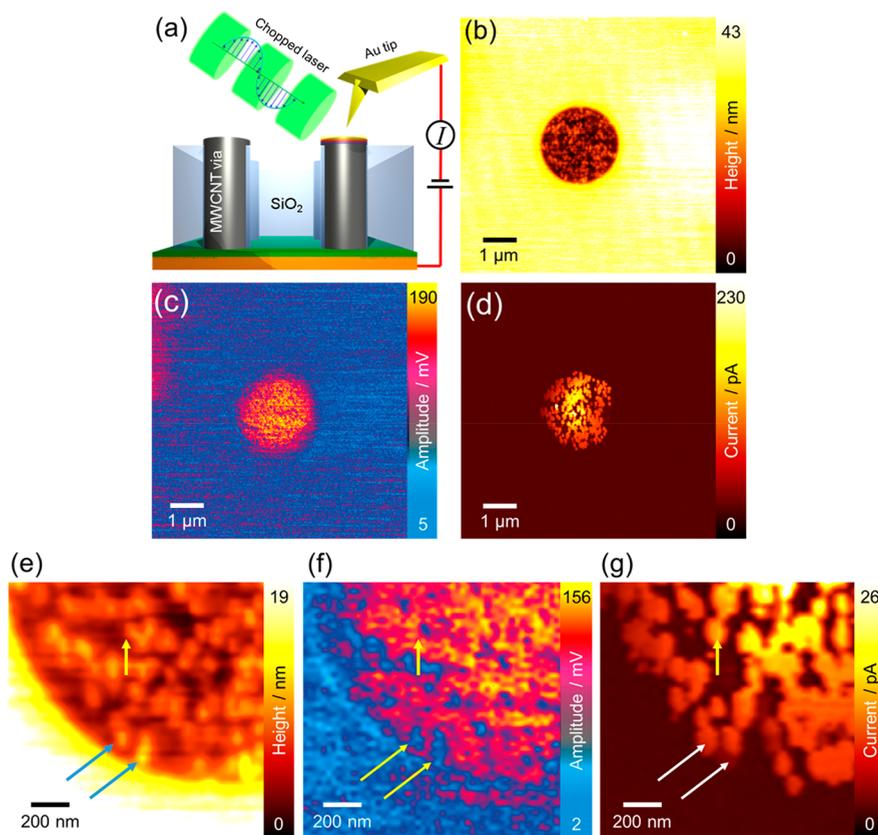


Figure 5. (a) Side-view sketch (nonscaled) of the MWCNT via configuration during nano-vis and current sensing AFM. (b) Topography, (c) nano-vis, and current images of an MWCNT via interconnect and zoom-in images (e), (f), and (g) on the left bottom corner of the via in images (b)-(d).

427 heterogeneities observed is due to the differences in the amount
428 of material, we then can attribute the different contrast in
429 Figure 2 to the density of MWCNTs. Indeed, in the SEM cross-
430 section image, we can see MWCNT bundles and voids.

431 If we consider the thermal conductivity of the MWCNT as a
432 source of image contrast, then the defects should also play a
433 role in nano-vis. The results of defects in carbon nanotubes
434 would impact the thermal conductivity of the material,
435 decreasing it. The reason behind this is the increase in phonon
436 scattering with defects that decrease the thermal conductivity of
437 graphene-like materials.³¹

438 Therefore, in addition to the increase in MWCNT density,
439 we expect that defects further increase the contrast in nano-vis.
440 This works the other way around too: if the MWCNT would
441 have lower defects due to a gentler sample processing, for
442 example, then the heat dissipation becomes larger, reducing the
443 contrast in nano-vis. To investigate this further, we focus now
444 on the MWCNT vias schematically shown in Figure 5a. The
445 high-resolution imaging results of a single MWCNT via are
446 displayed in Figure 5b–d for the topography, nano-vis, and
447 CSAFM. In Figure 5e–g we present the zoom-in images for
448 one part of the MWCNT via. It is worth noticing that the nano-
449 vis images in Figure 5c,f do not correlate with the topography
450 (Figure 5b,e) and only partially correlate with the current
451 (Figure 5d,g); this observation excludes the presence of
452 topographical artifacts. These images show clear distinctions
453 between the MWCNT and the SiO₂ matrix, demonstrating
454 once more the spatial resolution that can be obtained with
455 nano-vis. We also observed structures that are resolved inside
456 the MWCNT via, and it is particularly remarkable that we are
457 able to see individual carbon nanotubes in all three images.

Here again, we identify two different regimes for results shown
in Figure 5. One, the main contribution to the photothermal
expansion nano-vis images appears again to be dominated by
the optical absorption of the sample. The optically transparent
SiO₂ systematically shows a lower nano-vis contrast with
respect to the carbon nanotubes. The second regime observed
for changes in a single material is affected by the thermal
properties of the sample. Depending on the processing of the
MWCNT, we see that in one case with fewer defects on the
MWCNT top surface we are able to resolve individual tubes
(Figure 5). With fewer defects, the electrons and phonons have
larger mobility, which is reflected in the current and nano-vis
images, respectively; see Figure 5. We observe that the
individual MWCNTs do not show the largest contrast in
nano-vis results in Figure 5f. Notice that this was not the case
for the AFM topography image for the sample shown in Figure
2, in which individual MWCNTs cannot be seen, but rather a
nonhomogeneous and smooth surface. Another difference is
the protrusion of the MWCNT region over the SiO₂, while for
the via sample in Figure 4 the MWCNT topography is below
the surface of the SiO₂ matrix. The current and nano-vis results
in Figure 5 confirm the physical description illustrated in Figure
1a. That is, the electron–phonon scattering that follows optical
absorption induces contrast due to the photothermal expansion
of the sample transduced by the AFM cantilever. Differences in
heat conductivity due to changes in a sample, such as increased
defects or subsurface voids, also contribute to the contrast in
nano-vis. The situation is different for the CSAFM results since
the current observed in a via requires a certain degree of
structural stability all along the MWCNT interconnect from the
top down to the bottom electrode; see Figure S7.

489 ■ PERSPECTIVES

490 Notice the reasons that we used the samples here reported as a
 491 model system for nano-vis: the MWCNT/SiO₂ have optically
 492 transparent and nontransparent domains^{32,33} with minimal
 493 surface topography differences that minimize contributions
 494 from imaging artifacts. The major demonstration of being able
 495 to visualize at the nanoscale two materials with entirely different
 496 optical absorption is a necessary step toward applying nano-vis
 497 in the investigation of more complex systems at different
 498 wavelengths. A follow-up application and demonstration of our
 499 method includes the study of a mixture of semiconducting and
 500 metallic single-walled carbon nanotubes (SWCNTs) that have
 501 well-defined optical resonances at different wavelengths in the
 502 visible range. While the topography would show where the
 503 nanotubes are, by acquiring two sequential nano-vis images
 504 under red and green laser excitations, one could visualize the
 505 semiconducting and metallic SWCNTs. This is also interesting
 506 for the case of more complex systems such as hybrid two-
 507 dimensional materials since nano-vis could provide useful
 508 information on the coupling of plasmons in the visible range
 509 similarly to recent reports on two-dimensional heterostructures
 510 with PTIR.^{19,34}

511 ■ SUMMARY AND IMPLICATIONS

512 We demonstrated a novel, inexpensive, and general way to
 513 visualize the optical absorption and photothermal expansion
 514 using a conventional AFM. The spatial resolution of nano-vis
 515 imaging was obtained beyond the diffraction limit of light. This
 516 was demonstrated in the two-sample systems studied in this
 517 work: a semiconducting 2D material and metallic MWCNTs.
 518 The remarkable resolution with values as good as ~4 nm was
 519 found to be at least as good or even better than the topographic
 520 image in AFM but providing complementary information about
 521 the sample. This development opens the door for the low-cost
 522 analysis and characterization of optical and electronic properties
 523 of nontransparent samples at the nanoscale. It is worth noticing
 524 that the visualization of optical absorption at the nanoscale
 525 remained a challenging task that our work now simplifies.

526 The method here reported contributes to the development of
 527 novel ways for nanoscale characterization by paving the way to
 528 the inexpensive and widespread integration of nano-vis in
 529 conventional AFM devices. This opens now new possibilities
 530 for AFM as a toolbox with optics making a tremendous impact
 531 in key fields from cell biology³⁵ to energy harvesting,³⁶ for
 532 example, by making the visualization of nonradiative recombi-
 533 nation in organic solar cells possible³⁷ and the study of
 534 thermoelectric materials,³⁸ providing simultaneous nanoscale
 535 information on the thermal and electrical conductivities.

536 ■ MATERIALS AND METHODS

537 A conventional AFM (S420) from Keysight Technologies was
 538 coupled with a semiconductor cw laser modulated by a tunable
 539 mechanical chopper with a maximum chopping rate of 10 kHz.
 540 The laser beam of 514.7 nm (2.41 eV) with an intensity of 6
 541 mW was focused on the tip-sample region using a 10× LWD
 542 objective (NA 0.2). The fine focus is controlled using a
 543 piezoelectric steering mirror and a piezoelectric linear motor to
 544 adjust the spot focus at the tip/sample region. For the
 545 MWCNT interconnects and the CSAFM results an AIST-NT
 546 Omega Scope AFM was used, with a side illumination laser
 547 excitation at 532 nm wavelength focused on the tip with a 100×
 548 LWD objective (NA 0.7).

The Cantilever. The resonance frequency f_0 of a 549
 rectangular cross-sectioned cantilever depends on its geometry 550
 (length l and thickness h), density ρ , and its Young's modulus E 551
 according to the expression³⁹ $f_0 \propto \sqrt{\frac{E}{\rho}} \frac{h}{l^2}$. Therefore, our first 552
 concern regarding the possibility to obtain a Au cantilever with 553
 the proper resonance frequency implied tuning the cantilever 554
 dimensions, in particular by increasing its length due to the 555
 inverse square root dependence on this parameter. 556

Finite element method simulation results in Figure S1a of the 557
 Supporting Information showed that a length on the order of 558
 1000 μm should provide oscillation frequencies compatible 559
 with those of the mechanical chopper. This was experimentally 560
 verified as shown in Figure S1b by measuring the resonance 561
 spectrum of such long cantilevers using the built-in piezo- 562
 electric excitation by the AFM. Following a previously reported 563
 method,²⁴ we reproducibly obtained cantilevers with resonance 564
 frequencies below 10 kHz (see Figure S1b). Scanning electron 565
 microscopy images of the cantilever and the tip apex are shown 566
 in Figure 6. The second challenge was using these cantilevers in 567 66

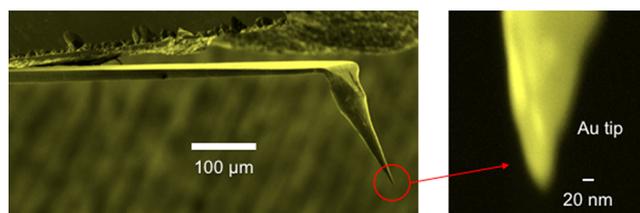


Figure 6. Scanning electron microscopy imaging of the fully metallic cantilever and zoom-in on the tip apex.

our nano-vis setup in a side-illumination configuration. The 568
 configuration of the tip-sample and laser is shown in the 569
 sketch in Figure 1b. 570

The Samples. The MWCNT sample in SiO₂ is an excellent 571
 sample for testing purposes given the clear separation between 572
 the two materials and the contrast between optical absorption 573
 and thermal coefficients of MWCNTs and SiO₂. The SiO₂ has 574
 very low absorption under the laser excitation used and 575
 therefore is expected to induce a much lower deflection 576
 amplitude of the cantilever. For the MWCNT region, the 577
 contrast is expected to be much higher as a direct consequence 578
 of higher absorption. 579

To prove the applicability of this method, we tested our 580
 system with another sample, GaSe on HOPG. We chose GaSe 581
 not only because of its well-defined interface with HOPG but 582
 also because it has an energy band gap of about 2 eV (see 583
 Figure S2 in the Supporting Information), so the green 584
 excitation at 2.41 eV is above the absorption edge, ensuring that 585
 a significant number of photons get absorbed. The other 586
 important reason for using GaSe as a relevant system is that its 587
 surface is atomically flat. The consequence of this flatness is 588
 that it minimizes any contribution to the cantilever oscillation 589
 (nano-vis) originating from changes in topography (cross-talk 590
 and other imaging artifacts). 591

592 ■ ASSOCIATED CONTENT

593 Supporting Information

The Supporting Information is available free of charge on the 594
 ACS Publications website at DOI: 10.1021/acspphoto- 595
 nics.8b00590. 596

597 Numerical simulations of the cantilever oscillation, the
598 optical absorption of GaSe, and effects of chopping
599 frequency and illumination (PDF)

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606 Author Contributions

607 R.D.R. conceived, designed, and implemented the experiments
608 and wrote the manuscript draft. T.I.M. and E.B. contributed to
609 the realization of experiments and analysis of the results. E.S.
610 contributed to the design and conception of this work. H.S. and
611 Y.P. contributed to the experimental implementation of nano-
612 vis. A.M. contributed to the realization of the nano-vis and
613 CSAFM experiments on the MWCNT vias. R.D.R., M.H., and
614 D.R.T.Z. assisted with the supervision of this work, proof-
615 reading the manuscript, and the interpretation of the
616 experimental results. All authors read and approved the
617 manuscript.

618 Notes

619 The authors declare no competing financial interest.

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